

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hiroshi MORIOKA**

Art Unit: **1756**

Application Number: **10/692,722**

Examiner: **Daborah Chako-Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. § 1.116**  
**EXPEDITED PROCESSING REQUESTED**

**MAIL STOP: AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

July 14, 2008

Sir:

This paper is filed in response to the Office Action dated February 13, 2008. The response date having been extended by two months to July 13, 2008 (Sunday) by the Petition for Extension of Time filed herewith.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.